



Docket No.: 204552031400
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Nobuhiro OHKUBO et al.

Application No.: 10/786,479

Confirmation No.: 3112

Filed: February 26, 2004

Art Unit: 2828

For: SEMICONDUCTOR LASER DEVICE AND
MANUFACTURING METHOD THEREOF

Examiner: T. T. Van Roy

AMENDMENT UNDER 37 CFR 1.116

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated September 1, 2006, please amend this application as follows.

Amendments to the Claims begin on page 2.

Remarks/Arguments begin on page 5.

Not Entered

12/13/06

TVR